

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

In re Application of: )  
Vyvoda et al. )  
Serial No.: 09/918,853 ) Examiner: Toledo, Fernando L.  
Filed: July 30, 2001 ) Group Art Unit: 2895  
For: Process for Fabricating a Dielectric )  
Film Using Plasma Oxidation )

**AMENDMENT**

Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Dear Sir:

Please enter the following amendment and remarks in response to the PTO

Communication mailed March 24, 2010.